

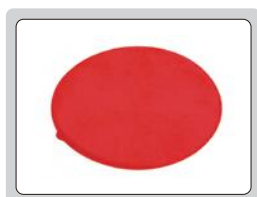
# MANUAL GRINDER AND POLISHER (BASIC TYPE) CODE MLP-GP314



- Double wheels, rotation direction can be selected
- Smooth rotation, low noise
- Water cooling device, prevent samples from overheating and destroying structure
- Replaceable silicon carbide paper and polishing cloth for grinding and polishing process



silicon carbide paper(included)



polishing cloth(included)



magnetic pad(optional)



anti-stick disc(optional)

## SPECIFICATION

Wheel diameter	Ø203mm
Wheel rotation speed	0~1400r/min(stepless adjustable)
Wheel rotation direction	clockwise or counterclockwise
Power supply	AC 220V, 50Hz
Input power	0.75KW
Dimension	755×700×310mm
Weight	50kg

## STANDARD DELIVERY

Main unit	1pc
Silicon carbide paper	5 pcs each, (240, 400, 800, 1200) 20 pcs in total
Polishing cloth	4 pcs
Polishing agent	1pc(W2.5, 500ml)

## OPTIONAL DELIVERY

Silicon carbide paper	MLP-SZ□□*	diameter: Ø200mm 120, 180, 240, 400, 600, 800, 1000, 1200, 1500, 2000, 2500, 3000
Polishing cloth	MLP-CT□□*	Ø200mm
Diamond polishing liquid	MLP-DLA□□*	500ml, select granularity (µm): W40, W28, W20, W14, W9, W7, W5, W3.5, W2.5, W1.5, W1.0, W0.5, W0.25
Diamond spray polish agent	MLP-DSA□□*	350ml, select granularity (µm): W40, W28, W20, W14, W9, W7, W5, W3.5, W2.5, W1.5, W1.0, W0.5, W0.25
Magnetic pad	MLP-AD1	Ø203mm
Anti-stick disc	MLP-DC1	Ø203mm

\* □□ is granularity specification, for example, code **MLP-SZB120** indicates 120 grit Ø200mm sandpaper without adhesive backing.